



Patent
Attorney's Docket No. 1003510-000164

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of) MAIL STOP AMENDMENT
Masafumi MIYAKAWA et al.)
Application No.: 10/507,245) Group Art Unit: 1711
Filed: September 10, 2004) Examiner: JEFFREY C MULLIS
For: PRESSURE-SENSITIVE ADHESIVE) Confirmation No.: 9077
FILM FOR THE SUFACE PROTECTION)
OF SEMICONDUCTOR WAFERS AND)
METHOD FOR PROTECTION OF)
SEMICONDUCTOR WAFERS WITH)
THE FILM)

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 18, 2005, please amend the
above-identified patent application as follows: